

1/18 REGINALD R. BOWLEY, JR., ET AL. (WDS) BUR920010128US1

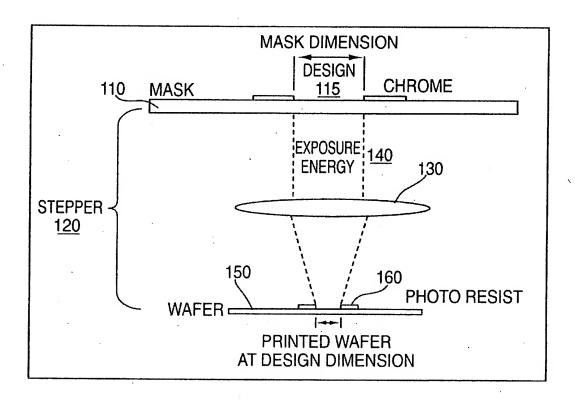
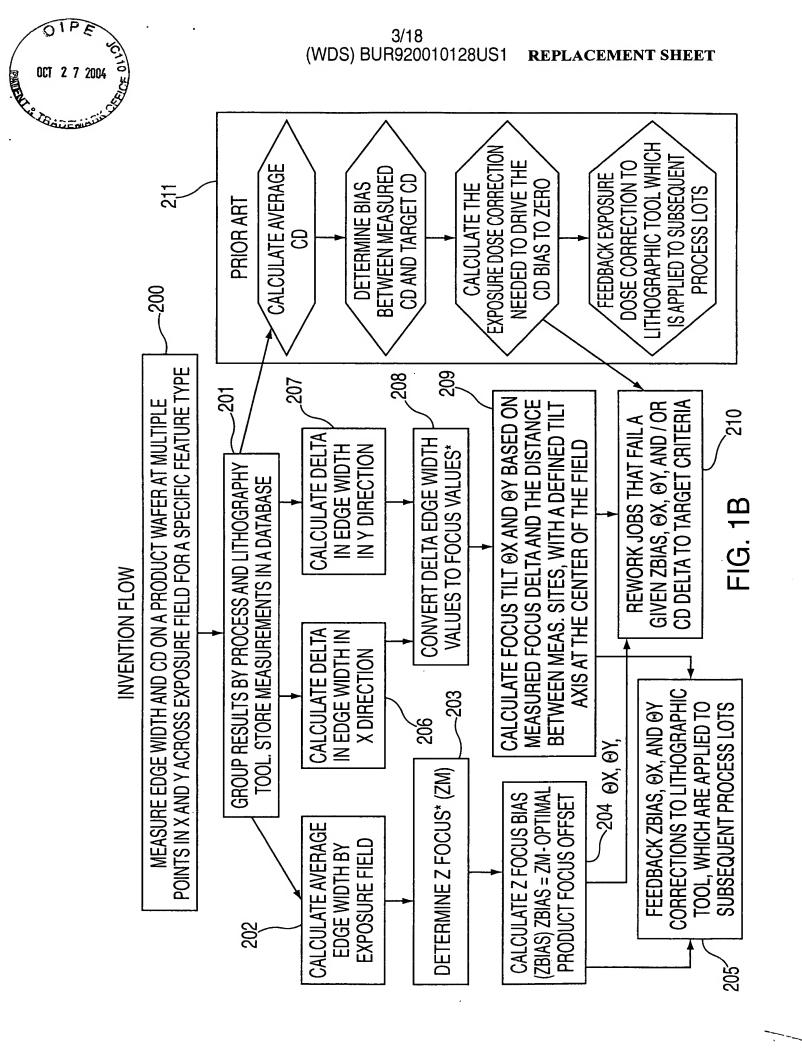


FIG. 1
PRIOR ART





SEM WAVEFORM VS. IMAGE PROFILE

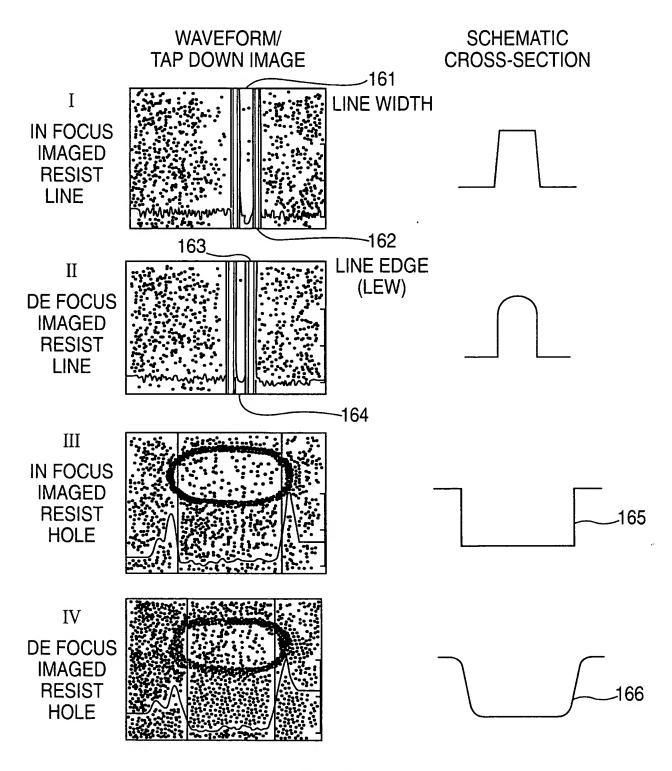


FIG. 1C



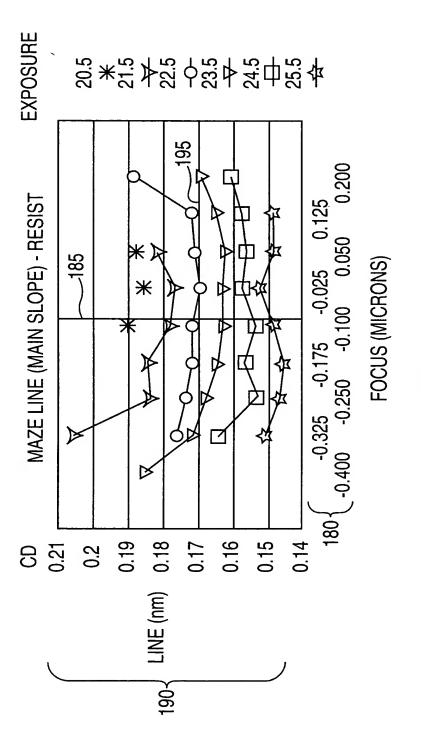
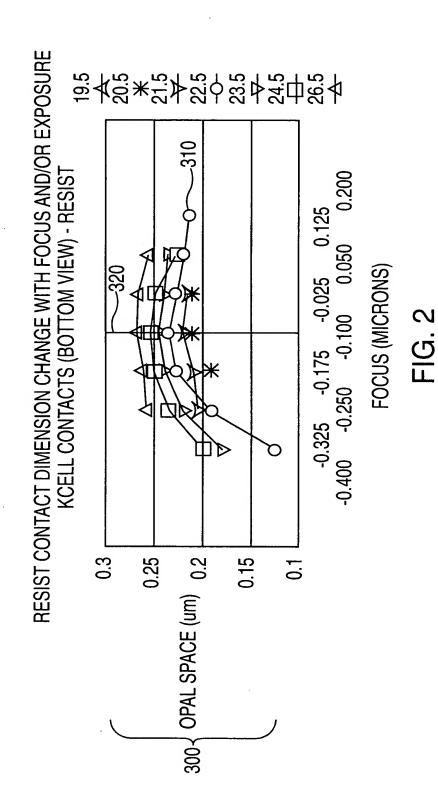
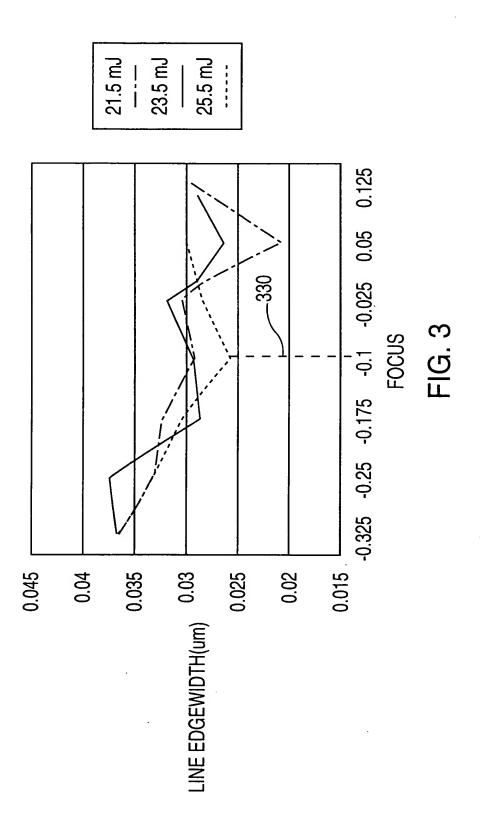


FIG. 1D

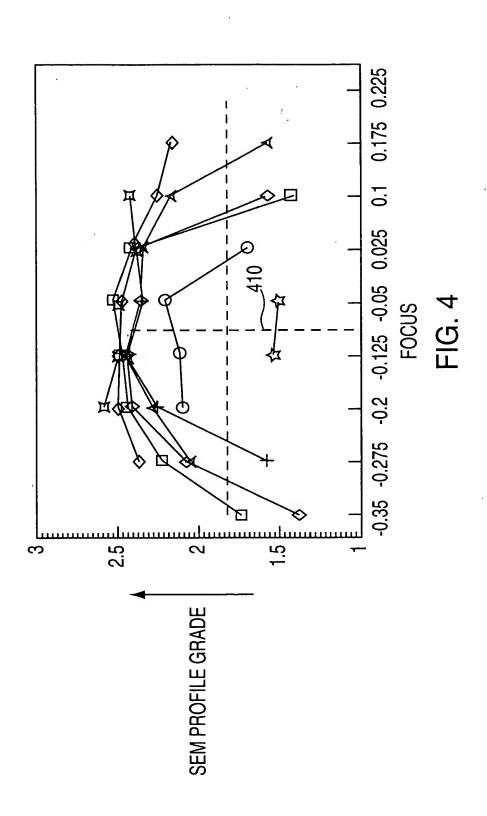














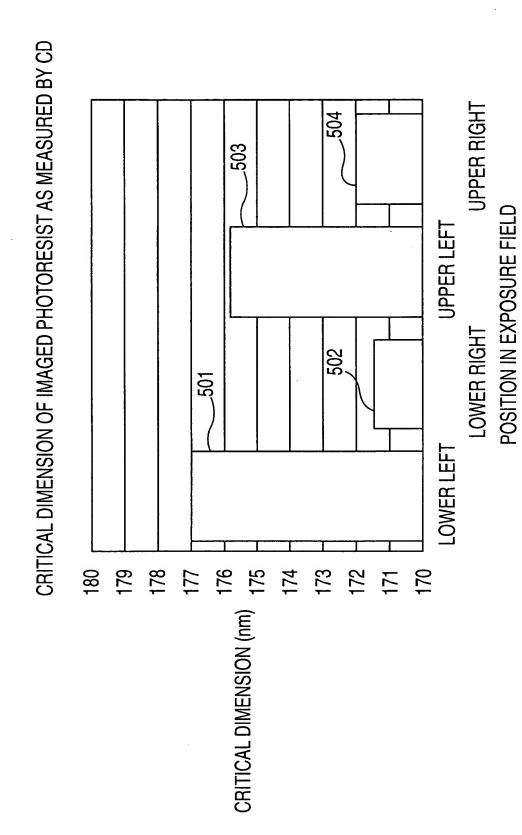


FIG. 5



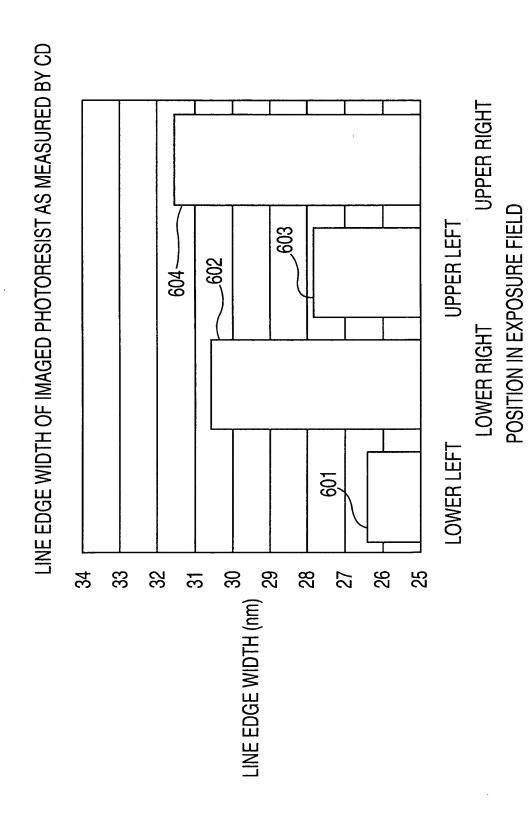


FIG. 6



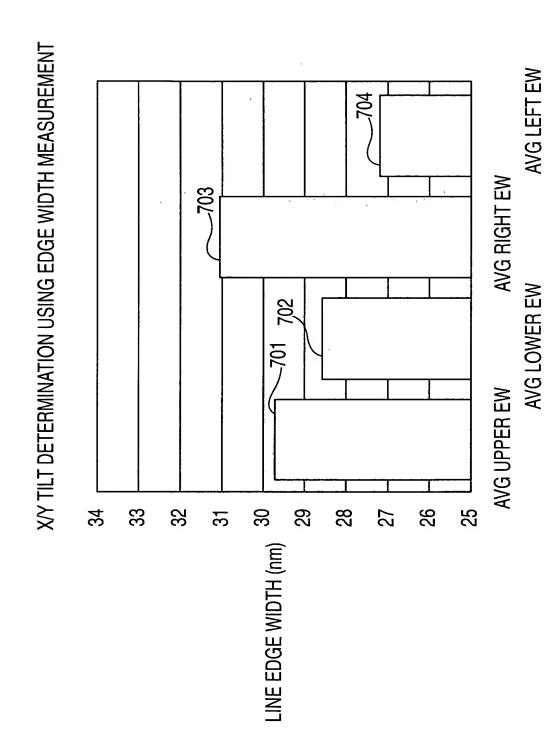
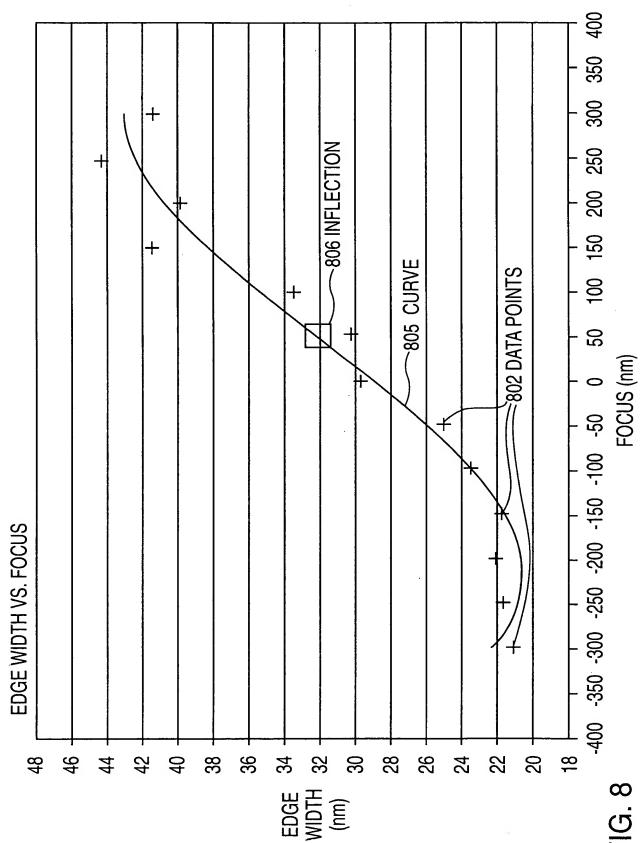
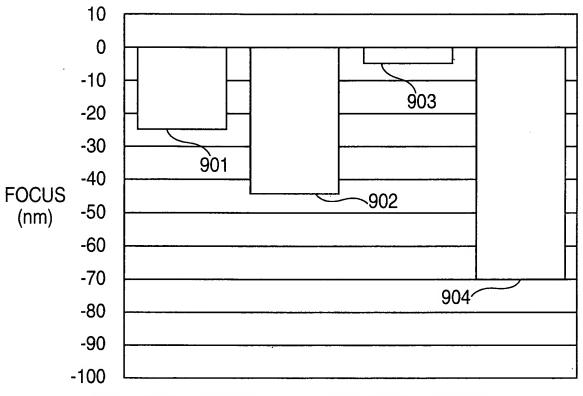


FIG. 7





X/Y TILT DETERMINATION USING EDGE WIDTH MEASUREMENT



AVG UPPER FOCUS

AVG RIGHT FOCUS

AVG LOWER FOCUS

AVG LEFT FOCUS

FIG. 9



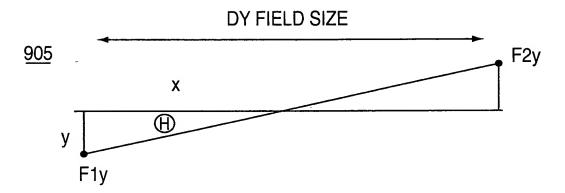
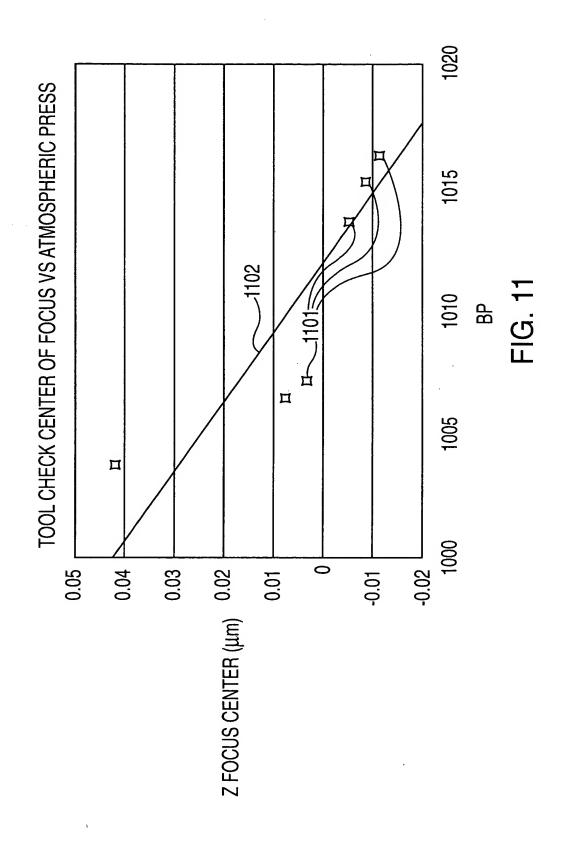
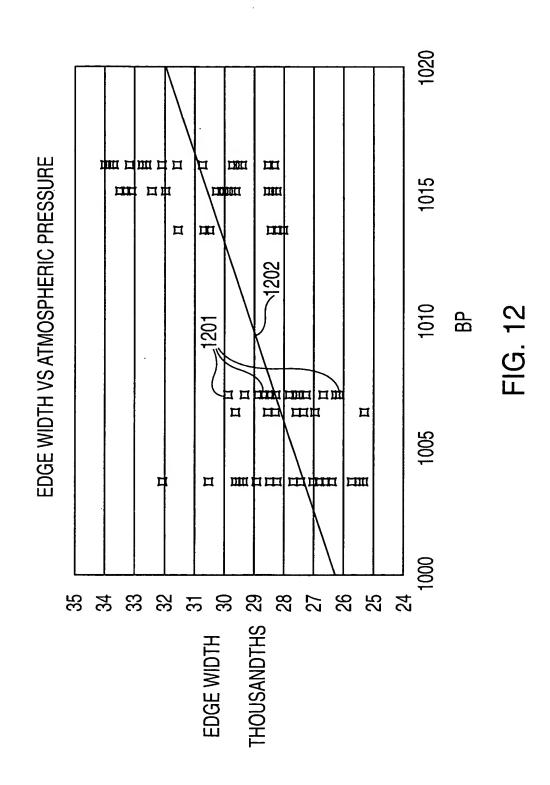


FIG. 10











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2	Y	2
	Z	2
L (5
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F	1	: วั

1370 FOCUS	0.10	0.10	0.10	0.00	-0.10	-0.10	-0.10	-0.05	-0.10	-0.10	-0.10	-0.10
1360 DEFAULT EXPOSURE	19.00	19.00	19.00	20.00	24.00	30.00	30.00	28.00	25.00	24	30.00	30.00
1350 OPT	ட	ய	ட	ட	ட	Ц.	Щ.	ட	ட	ட	ட	ш_
1340 PROCESS	MC	MC	MC	MC	MC9S	MC9S	MC9S	MC9S	MC9S	MC9S	MC9S	MC9S
1330 WAFERPN	*	*	*	*	*	0000008J0640	0000008J0645	0000057P6438	*	*	000000870639	000000830640
1320 TECHNOLOGY	ICE8S3D	ICEC8S2	ICEC8S3	CMOS6X1	CSO19S0	CSO19S0	CSO19S0	CSO19S0	CSO19S2	CSO19S0	CSO19S0	CSO19S0
1310 TOOL	U82V	U82V	U82V	U84V	N98N	N98N	N98N	N98N	N86V	U92V	U92V	U92V

FIG. 13 (PRIOR ART)



FOCUS ERROR CONTROL LOOP

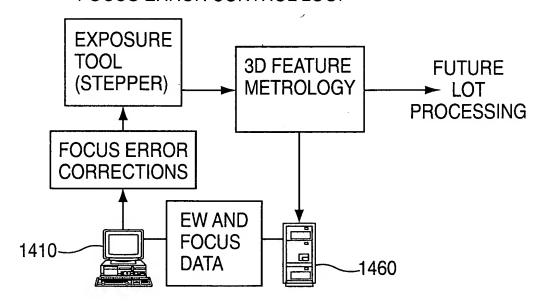


FIG. 14